

Notice of References Cited

Application No.

52392

Applicant(s)

Nakamura et al

Examiner

RL Schilling

Group Art Unit

1752

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☆		DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS
A		5352 562	10/1994	Takahashi et al	434	253
B		6468634	10/2002	Miyake et al	438	195
C						
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N		2000/225776	8/2000	Japan	Miyake et al		
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T							

NON-PATENT DOCUMENTS

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